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**Balaji Panchapakesan
André-Jean Attias
Wounghang Park**
Editors

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Contents

MICRO AND NANO OPTICS

- 11467 03 **Natural in-plane hyperbolic crystals for far-infrared optical components** [11467-2]
- 11467 04 **Optical computing with photonic CMOSFETs: A new way to look into process integration, circuit, and layout designs for next generation ULSI or mixed-signal ASICs** [11467-3]
- 11467 06 **Amplitude and phase engineered all-dielectric metasurface for finite energy self-accelerating airy beam generation** [11467-5]
- 11467 07 **Implementing of inverse designed power splitters by using effective medium theory** [11467-6]
- 11467 08 **Identification of zirconia and hafnia crystalline phases by optical spectroscopy from first-principles** [11467-7]
- 11467 09 **Photonic bandgap optimized by artificial bee colony algorithm** [11467-8]

NANOMANUFACTURING OF 1D AND 2D NANOMATERIALS FOR PHOTONICS APPLICATIONS

- 11467 0D **Process repeatability in volume manufacturing of nanostructures utilizing nanoimprint lithography** [11467-12]

DEVICES AND PROPERTIES OF NANOSTRUCTURES FOR PHOTONICS AND BIOMEDICAL APPLICATIONS

- 11467 0J **Simulation and modeling of fabricated metasurface optical device measured via polarimetric scatterometer** [11467-18]
- 11467 0K **Performance analysis of thin film CIGS solar cell at different values of thickness, bandgap and temperature through numerical simulation** [11467-19]

LIGHT-MATTER INTERACTIONS IN 1D AND 2D NANOMATERIALS

- 11467 0O **Spectroscopy using tunable liquid crystal Fourier filters** [11467-23]
- 11467 0Q **Ultra-low landing energy scanning electron microscopy for nanoengineering applications and metrology (Invited Paper)** [11467-25]
- 11467 0S **Wavelength-tunable planar plasmonic absorber based on PCM's nanoresonators** [11467-27]

PHOTON UPCONVERSION I

- 11467 0X **Surface engineering of small and bright upconversion nanoparticles providing chemical and colloidal stability in biological media (Invited Paper) [11467-31]**
- 11467 0Y **Visible upconversion photoluminescence of bulk silicon and mesoscale silicon nanoparticles [11467-32]**

INNOVATIVE PATTERNING, MATERIALS ENGINEERING, NANOFABRICATION, AND NANOLITHOGRAPHY FOR PHOTONICS AND BIOMEDICAL APPLICATIONS

- 11467 1H **Processing of organic electro-optic materials for commercial applications [11467-51]**
- 11467 1I **Innovative patterning of electrospinning fabrication nano scaffolds with cell culturing for liver tissue engineering [11467-52]**
- 11467 1K **Hybrid plasmonic substrates fabricated by a nanoline-gap-modulated assembly of nanoparticles [11467-54]**

NANOSTRUCTURED THIN FILMS AND DEVICES

- 11467 1O **Birefringence analysis of photo-addressable azopolymer thin films from spatial frequency response of focused surface plasmon [11467-58]**
- 11467 1R **Characterization of C-Ti multilayer thin films obtained by TVA technology [11467-61]**
- 11467 1U **Magnetically tunable visible reflectivity utilizing the electron accumulation in indium-tin-oxide waveguide layer with subwavelength grating [11467-64]**
- 11467 1V **Formation of all-silica sculptured thin films based optical elements on crystal substrates [11467-65]**

POSTER SESSION

- 11467 1Y **Analysis of tilted subwavelength periodical waveguides: polarization effects [11467-68]**
- 11467 1Z **Properties of carbon nanoparticles for diagnostics of speckle fields [11467-69]**
- 11467 20 **Investigation of stochastization of optical radiation scattered by polydisperse carbon nanoparticles [11467-70]**
- 11467 21 **Synthesis of antibiotic-silver nanoparticles complexes, their properties, and application for investigation of antibiotic-resistance mechanisms [11467-71]**
- 11467 22 **Thermal effects analysis in photonic crystal resonant cavities [11467-72]**

- 11467 29 **Waveguide crossing design using particle optimization algorithm** [11467-79]
- 11467 2A **Narrowband plasmonic absorber with phase-change-material layer** [11467-80]
- 11467 2H **Ab-initio study of oxygen and carbon contamination on GaAs(100) planar and nanowire photocathode** [11467-87]
- 11467 2I **Ultra-steep-slope transistor enabled by an atomic memristive switch** [11467-88]
- 11467 2J **Sensitivity optimization of an evanescent field particle detector based on a silicon nitride waveguide** [11467-89]
- 11467 2K **Fast optical humidity sensor based on nanostructured hydrogels** [11467-90]